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(54) GAS SUPPLY PROCESS AND APPARATUS

British Company, Haverton Hill Road, Billingham, Teesside, do hereby declare the invention, for which we pray that a patent 5 may be granted to us, and the method by which it is to be performed, to be particularly described in and by the following statement:-

The present invention relates to a process 10 and apparatus suitable for the production of finely-divided metal oxides by the oxidation of the corresponding metal halides at high

temperatures.

In our British Patent No. 1,097,764 there 15 is described a process and apparatus for the production of finely divided metal oxides by the oxidation, at elevated temperature, of the vapour of the corresponding halide. The process and apparatus claims of this 20 specification are directed to the introduction into one end of a reaction zone of an archeated primary gas (which may be an inert gas or one of the reactants) and the introduction into that primary gas of a secondary 25 gas (which may be the oxidising gas and/or the metal halide) through an injector which forms at least part of the wall of the reaction zone and thus surrounds the primary gas stream and which is provided with aper-30 tures through which the secondary gas enters after it has been supplied in such a manner as to cool the wall of the injector device before entering the reaction zone through the apertures (and is thus preheated in doing 35 so). Figures 5 and 6 of British Patent No. 1,097,764 show preferred embodiments of the apparatus and methods of operating the apparatus shown in these Figures are described in Examples 1 and 2 of the speci-

It has now been found that apparatus and processes similar to those described in British Patent No. 1,097,764 suffer from certain disadvantages, particularly in injec-45 tion devices such as those shown in Figures

We British Titan Limited a 5 and 6, e.g. devices of increased length and which are provided with a large number of

holes spaced along the wall of the device. It is an object of this invention to provide apparatus and process which reduces or 50 eliminates these disadvantages.

Accordingly, the present invention is a

process for the production of finely-divided metal oxides by the oxidation of the corresponding metal halide comprising introducing 55 into one end of a reaction zone a hot stream of primary gas consisting of an inert gas or the oxidising gas or the metal halide, in-troducing into the primary gas stream through an injection device which forms at 60 least part of the wall of the reaction zone and which contains a plurality of apertures a secondary gas consisting of the oxidising gas and/or the metal halide, the secondary gas being supplied to the injection device 65 in such a manner that it cools the injection device and is thereby preheated before it passes through the apertures into the primary gas stream and wherein the apertures are formed with at least two different cross- 70 sectional areas along their length, the smaller cross-sectional area being at the inlet end of the aperture for the secondary gas.

The invention also comprises an apparatus suitable for the oxidation of a metal 75 halide comprising a reactor having inlet and outlet ports at opposite ends and surrounded at least in part by an injection device which forms at least part of the wall of the reaction zone and which has a plurality of 80 apertures, means to supply a gas or vapour to the injection device in such a manner that the gas or vapour passes over at least part of the wall of the injection device before entering the reactor through the apertures 85 and in which the apertures are formed with at least two different cross-sectional areas along their length, the smaller cross-sectional area being at the inlet end of the aperture

for the gas or vapour.

It has been found that apparatus of the type described in British Patent No. 1,097,764 and particularly in Figures 5 and 6 of that specification, may suffer from sig-5 nificant accretion of metal oxide around the edge of the apertures through which the secondary gas enters the primary gas stream. This is particularly noticeable when using longer injection devices with a large number 10 of apertures. At least one reason for this is believed to be the substantial pressure drop between the inlet port for the primary gas and the exit port for the reaction products necessitating the introduction of the 15 secondary gas through the apertures at higher velocity than in shorter injection devices in order to ensure acceptable distribution of the gas through the apertures around the injection device. However, the higher 20 velocity of the secondary gas entering the primary gas stream from the apertures tends to cause eddies and recirculation of the mixing reactants at that point which, in turn, causes the reactants to impinge upon the 25 wall of the injection device, particularly around the apertures giving rise to deposition and accredition of metal oxide.

It has now been found that this disadvantage can be avoided if provision is 30 made, after the secondary gas has entered the aperture at the required velocity for acceptable distribution, to reduce the velocity of the gas stream before it enters the stream of primary gas. The reduction 35 in the velocity of the gas within the aperture is accomplished by increasing the cross-sectional area of the apertures between the first part of the apertures, the cross-sectional areas of which are carefully determined to 40 ensure the desired distribution of the secondary gas through all the apertures, and the exit orifices into the primary gas stream.

The cross-sectional areas of the first part

of the apertures which is necessary to en-45 sure the desired distribution of the secondary gas through the apertures depends upon a number of factors, for example the gas pressure in the reaction zone, the volume of secondary gas to be introduced through 50 the available apertures and the pressure at which the secondary gas can be supplied to the apertures initially and it is not possible, therefore, to give exact dimensions for this value. Generally, however, it has been 55 found convenient to provide apertures in which the first part is a circular orifice having a diameter in the range 0.01 inches to 0.20 inches, particularly from 0.01 inches to 0.10 inches, and preferably one in the range 60 0.02 inches to 0.10 inches, particularly from 0.02 inches to 0.06 inches. It is, of course, not necessary that such orifices should be circular but these are preferred for ease of production.

65 Normally, the size of the first part of the

aperture, i.e. the smaller diameter is selected to provide a pressure drop across this part of the aperture of from 0.1 to 10 p.s.i.g. and particularly of from 0.5 to 5 p.s.i.g., the preferred pressure drop within these ranges 70 depending upon the scale of operation.

Normally, the first part of the aperture is of constant cross-sectional area from 10% to 50% of the length of the aperture, after which the cross-sectional area is increased 75 sufficiently and for a sufficient distance to reduce the velocity of the gas to the required value. Again, these dimensions are difficult to specify for all cases but it has been found generally suitable to increase the cross- 80 sectional area by increasing the diameter of the aperture (where circular) to a value in the range 0.05 inches to 0.50 inches and preferably to one in the range 0.10 inches to 0.30 inches, for the remaining length of 85 the aperture, e.g. for a distance of at least 1.5 times and preferably at least 3 times the

diameter of the larger aperture.

The total length of the aperture will, of course, depend upon the thickness of the 90 wall of the injection device at that point and if this is small it may be preferable to increase progressively the cross-sectional area of the aperture to obtain the necessary reduction in the velocity of the secondary 95 gas before it enters the primary gas stream.

It is essential for the purpose of the present invention that the cross-sectional area of the aperture should be increased after the first entry orifice and normally 100 there are only two differing cross-sectional areas along the aperture. However, if desired, the cross-sectional area may be increased more than twice, for example three or four times or it may, if desired, be continuously increased from the smaller cross-sectional area to the exit orifice into the primary gas stream.

It is preferred that the injection device is of metal for ease of fabrication and for 110 good heat conducting properties. Particularly suitable metals are aluminium, nickel and alloys of these metals or stainless steel.

It is also preferred that each group or groups of apertures through which the same 115 secondary gas is to be introduced should be supplied by a common manifold via a jacket surrounding that group or groups of apertures since this simplifies the pipe work required for the supply of the secondary 120 gas or gases and improves the cooling of the injection device.

Where longer injection devices are used, in particular, problems of expansion and contraction may arise and these can be avoided by providing for expansion by any suitable means, for example, by forming the injection device in sections with "steps" between which allow for expansion. Such steps can, if desired, be spring loaded. 130

Similarly, the surrounding jacket(s) to which the secondary gas or gases are supplied before entering the apertures may be in the form of bellows (which may also be spring-5 loaded) to accommodate expansion and contraction.

The secondary gas is either premixed oxidising gas and metal halide, for example oxygen and titanium tetrachloride 10 (with additives such as silicon tetrachloride and/or aluminium chloride, if required) or it may consist of the oxidising gas or the metal halide (which may be separately introduced through different groups of aper-15 tures in the same injection device, again each containing an additive(s), if desired).

If the primary gas is an inert gas which is merely used as a heat carrier then both reactants are, of course, normally 20 introduced through the injection device. If one of the reactants constitutes the primary gas then only one reactant need to be introduced through the injection device. It is preferred, however, to use part of one re-25 actant, for example oxygen, as the primary gas and to introduce the remaining oxygen and the metal halide either premixed and/or separately through the injection device (with appropriate additions of aluminium chloride 30 and/or silicon tetrachloride where the metal halide is titanium tetrachloride).

The primary gas is preferably arc-heated as described and claimed in British Patent No. 1,097,764 but is not necessarily so. 35 For example, it may consist of any suitable gas composition capable of initiating and maintaining the oxidation of the metal halide such as the cumbustion products of carbon monoxide or a hydrocarbon gas 40 although, in the latter case, the presence of water will lead to the formation of hydrogen chloride which may be undesirable.

The products of reaction are preferably collected by conventional means such as 45 sock filters after initial cooling, for example by means of a primary cooler and by mixing with recycled tail gas. Alternatively, they may pass into a reactor in which more metal halide is being oxidised to the corres-50 ponding metal oxide. In such cases the products of reaction from the present invention may form nuclei for the subsequent oxidation of metal halide.

Finally, where the product is a pigment-55 ary metal oxide such as titanium dioxide, it will normally be subjected to conventional after-treatments such as classification, coating, drying and/or milling before use

The Figure of the drawings accompany-60 ing the Provisional Specification shows one embodiment of the invention in which the hot primary gas enters through port (1) into injector/reactor (2) and leaves through exit port (3). A purge of gas is introduced 65 through (4) to maintain the face of the

apparatus producing the primary gas free from accretion and a coolant is introduced into (5) and withdrawn from (6) to minimise heat transfer from any subsequent reaction to the injection device (7). Premixed re- 70 actants forming the secondary gas are introduced through (8) into jacket (9) in which they flow over the outer surface of the injection device, thereby cooling it, before they enter the reactor containing the hot primary 75 gas via apertures (10). Apertures (10) represent diagrammatically numbers of apertures at each level of similar cross-section to those shown in which the reactants enter from the surrounding jacket through orifices (11) 80 of smaller cross-sectional area and leave the aperture through orifices (12) into the reactor (at reduced velocity compared with that at which they issued from orifices (11)).

The following Example describes one 85 method of carrying out the process of the present invention:

Example

A reactor of the type shown in the attached Figure was set up consisting of an 90 aluminium tube 5 inches outside diameter, 3 inches internal diameter and 6 inches long which was surrounded by a jacket into which premixed oxygen and titanium tetrachloride containing sufficient aluminium 95 chloride and silicon tetrachloride to produce 2% by weight of alumina and 0.3% silica respectively by weight on the TiO2.

The injector device was provided with a total of 392 apertures in 14 rows of 28. 100 Each aperture consisted of a first orifice of 0.047 inches diameter which extended for 0.20 inches after which the orifice was increased to a diameter of 0.125 inches for the remaining length of the aperture.

Oxygen (12 grams moles/minute) was preheated in a plasma gun sealed to the top of the injection device to an average tempera-ture of 3,400°K and passed into the reactor together with 1 g.mole/minute through inlet 110 (4). The premixed oxygen/titanium tetrachloride/aluminium trichloride/silicon tetrachloride mixture previously mentioned, preheated to 150°C, was introduced into the jacket surrounding the injection device at 115 a rate of 23 gram/moles oxygen and 24 titanium tetrachloride per gram/moles minute.

The titanium dioxide produced was recovered and found to be excellent quality. 120

The process was operated as described above for 48 hours after which the interior of the injection device was found to be substantially free of TiO2 accretion, particularly around the apertures.

From previous experience it was known that operating a similar process under similar conditions but with apertures of constant cross-sectional area (equal to that of the smaller orifice of the apertures referred to 130

above) over a similar period of time caused a noticeable accretion of TiO₂ on the interior injection device, particularly around the apertures.

WHAT WE CLAIM IS:-

1. A process for the production of finelydivided metal oxides by the oxidation of the corresponding metal halide comprising introducing into one end of a reaction zone a 10 hot stream of primary gas consisting of an inert gas, the oxidising gas or the metal halide, introducing into the primary gas stream through an injection device which forms at least part of the wall of the re-

15 action zone and which contains a plurality of apertures a secondary gas consisting of the oxidising gas and/or the metal halide the secondary gas being supplied to the injection device in such a manner that it cools

20 the injection device and is thereby preheated before it passes through the apertures into the primary gas stream and wherein the apertures are formed with at least two different cross-sectional areas along their 25 length, the smaller cross-sectional area be-

ing at the inlet end of the aperture for the secondary gas.

2. A process as claimed in claim 1 wherein the apertures are circular and have a 30 smaller cross-sectional area with a diameter in the range 0.01 inches to 0.20 inches.

3. A process as claimed in claim 2 wherein the diameter of the apertures is in the range 0.02 inches to 0.10 inches.

4. A process as claimed in any of the preceding claims wherein the pressure drop across the smaller cross sectional area of the apertures is from 0.1 to 10 p.s.i.g.

5. A process as claimed in claim 4 where-40 in the pressure drop is in the range 0.5 to

5 p.s.i.g.

6. A process as claimed in claim 1 wherein the smaller cross-sectional area of the apertures is constant and extends for from

45 10% to 50% of the length of the aperture. 7. A process as claimed in any of the preceding claims wherein the apertures are circular and the diameter of the apertures increases to one in the range 0.05 inches to 50 0.50 inches.

8. A process as claimed in claim 7 wherein the diameter of the apertures increases to one in the range 0.10 inches to 0.30 inches.

9. A process as claimed in any of the preceding claims wherein the apertures are circular and the diameter of the apertures

is increased for a distance of at least 3 times that of the larger diameter of the aperture.

10. A process as claimed in claim 1 60 wherein the cross sectional area of the aperture continuously increases from that of the smaller cross-sectional area.

11. A process as claimed in any of the preceding claims wherein the injection de- 65 vice is made of aluminium, nickel, alloys thereof or of stainless steel.

12. A process as claimed in any of the preceding claims wherein the primary gas is oxygen, and oxygen and metal halide com- 70 prise the secondary gas or gases.

13. A process as claimed in any of the preceding claims wherein the primary gas is heated by passage through an electric arc.

14. Apparatus suitable for the oxidation 75 of a metal halide comprising a reactor having inlet and outlet ports at opposite ends and surrounded at least in part by an injection device which forms at least part of the wall of the reaction zone and which has 80 a plurality of apertures, means to supply a gas or vapour to the reactor in such a manner that the gas or vapour passes over at least part of the injection device before entering the reactor through the apertures 85 and in which the apertures are formed with at least two different cross-sectional areas along their length the smaller cross-sectional area being at the inlet end of the aperture for the gas or vapour.

15. Apparatus as claimed in claim 14 wherein the injection device is formed in sections with steps between to allow for ex-

pansion. 16. Apparatus as claimed in claim 15 95

wherein the steps are spring loaded.

17. Apparatus as claimed in any of claims 14, 15 or 16 wherein the injection device is surrounded by a jacket or jackets in the form of bellows to allow for expan- 100 sion.

18. Metal oxide when produced by a process as claimed in any of claims 1 to 13 or in apparatus as claimed in any one of claims 14 to 17.

19. A process as claimed in any of claims 1 to 13 and substantially as described in the Example.

20. Apparatus substantially as described and shown in the drawing accompanying the 110 provisional application.

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